pplication No.	Applicant(s)
/562,864	VELIKOTNY ET AL.
aminer	Art Unit
iscal M. Bui-Pho	2878
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en received. en received in Application No ents have been received in this his communication to file a reply T of this application.	national stage application from the complying with the requirements 'S AMENDMENT or NOTICE OF tion is deficient. 948) attached Office action of the back) of d). must be submitted. Note the
5. Notice of Informal P 6. Interview Summary Paper No./Mail Dat 7. Examiner's Amendr 8. Examiner's Stateme 9. Other	(PTO-413), te
	on the cover sheet with the case REMAINS) CLOSED in this apportion is subject to the appropriate communication TS. This application is subject to the MPEP 1308. 35 U.S.C. § 119(a)-(d) or (f). Sen received. Sen received in Application Noents have been received in this application. I. Note the attached EXAMINER eason(s) why the oath or declarate submitted. Sen Patent Drawing Review (PTO-mendment / Comment or in the Case) should be written on the drawing eader according to 37 CFR 1.121(a) of BIOLOGICAL MATERIAL INTERIOR THE DEPOSIT OF BIOLOGICAL MATERIAL INTERIOR SAMENDAR IN

Continuation of Attachment(s) 3. Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date: 19 May 2006 & 12 April 2006.

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DETAILED ACTION

Priority

1. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Allowable Subject Matter

- 2. Claims 1-3 are allowed over prior art.
- 3. The following is an Examiner's statement of reasons for allowance:

The prior arts of record fail to anticipate and/or render obvious, either solely or in combination, an optoelectronic code-to-position encoder, comprising, among other features, a readout unit provided with a code analyzing mask including two arrays of windows with a period divisible by a code pitch and a width of each of said windows being equal to the code pitch, the windows of the code analyzing mask being shifted with regard to each other by a value equal to half of the code pitch, initial phases of the raster analyzing mask and one of the tracks of the code analyzing mask being aligned; the total width of tracks of the code analyzing mask being less than the height of windows of a code track of a coordinate scale (Claim 1).

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure:

I) Ohno et al. (US 5,068,529) disclose an absolute position detection encoder including a coder having a track provided with first graduations of an absolute pattern and second graduations of an incremental pattern.

II) Schwaiger et al. (US 5,294,793) disclose a system for measuring lengths or angles comprising a scale member provided with absolutely coded scale elements and incremental scale elements.

- III) Peterlechner (US 6,031,224) discloses a position measuring system including a scale and a scanning unit for scanning the scale and movable relative to the scale in a measuring direction, for generating position dependent measuring signals.
- IV) Schmitt (US 4,654,527) discloses a measuring system which includes a scale which defines a measuring graduation and an array of reference marks.
- V) Matsumoto et al. (US 5,563,408) disclose an absolute encoder having a coder in which an incremental pattern and an absolute pattern are arranged in parallel and a detector including sensors for detecting the incremental pattern and the absolute pattern, respectively.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Pascal M. Bui-Pho whose telephone number is (571) 272-2714. The examiner can normally be reached on Monday through Friday: 8:30 a.m. - 5:00 p.m.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Georgia Epps can be reached on (571) 272-2328. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Pascal M. Bui-Pho

Examiner, Art Unit 2878

20 September 2006

Georgia / pps
Supervisory Patent Examiner